Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/634,229	BANSAL, JAI P.	
Examiner	Art Unit	
Sun J. Lin	2825	

SEARCHED				
Class	Subclass	Date	Examiner	
716	1	2/11/2005	JSL	
716	7	2/11/2005	JSL	
716	8	2/11/2005	JSL	
716	9	2/11/2005	JSL	
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INTERFERENCE SEARCHED					
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